

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-2383		Priority SERIAL NO. 10/271,888	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Fernando Gonzalez			
					Priority FILING DATE October 15, 2002		Priority GROUP 2818	
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
4	AA 6,309,945 B1	10/01	Sato et al.					
	AB 5,296,449	03/94	Kikuchi					
	AC 5,374,564	12/94	Brud					
	AD 5,855,693	01/99	Murari et al.					
	AE 5,877,070	03/99	Goesle et al.					
	AF 5,882,987	03/99	Srikrishnan					
	AG 5,894,152	04/99	Jaso et al.					
	AH 5,953,622	09/99	Lee et al.					
	AI 6,004,406	12/99	Kobayashi et al.					
	AJ 6,251,754	6/01	Ohshima et al.					
	AK 6,245,161	6/01	Henley et al.					
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	AN 6,150,031	11/00	Yonehara					
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	AQ 6,423,992 B2	07/02	Fukuda et al.					
	AR 6,384,439 B1	05/02	Walker					
4	AS 5,998,847	12/99	Assaderaghi et al.					
FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
4	AT	Gösele, U. et al., "Semiconductor Wafer Bonding: Science, Technology, and Applications". Electrochemical Society Proceedings						
		Vol. 97-36, (©1998), pp. 400-425, 436-445.						
EXAMINER <i>calvinla</i>				DATE CONSIDERED <i>6.7.04</i>				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								